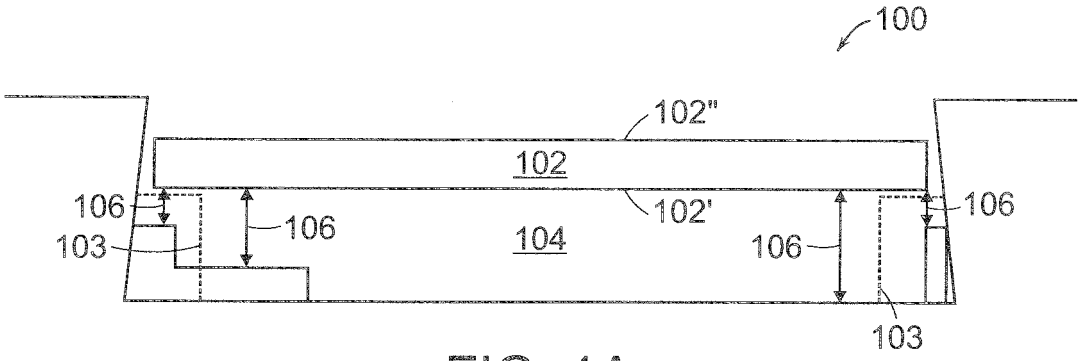


FIG. 1A

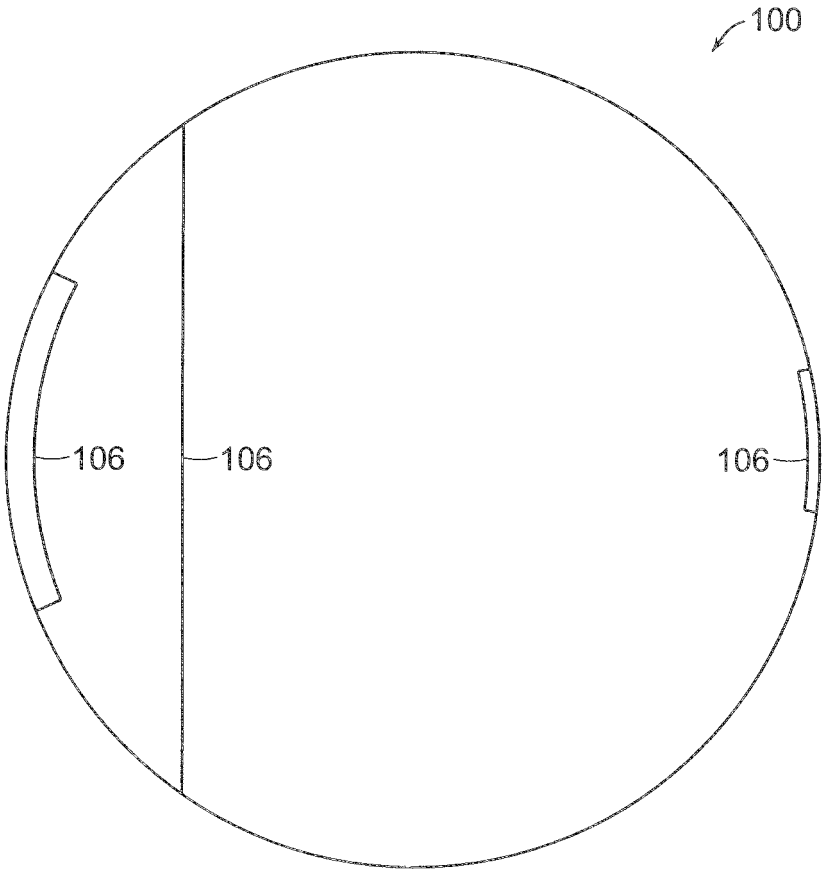


FIG. 1B

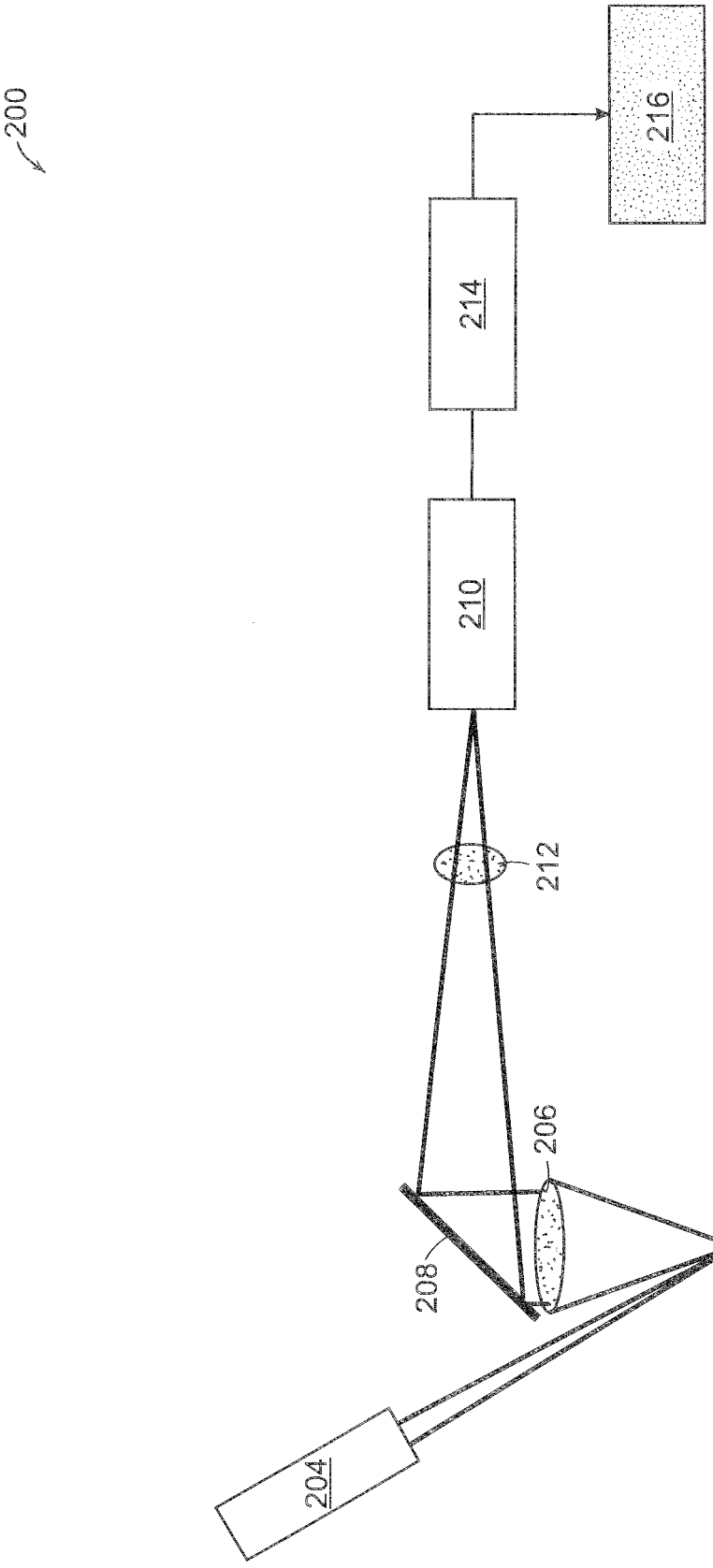


FIG. 2
PRIOR ART

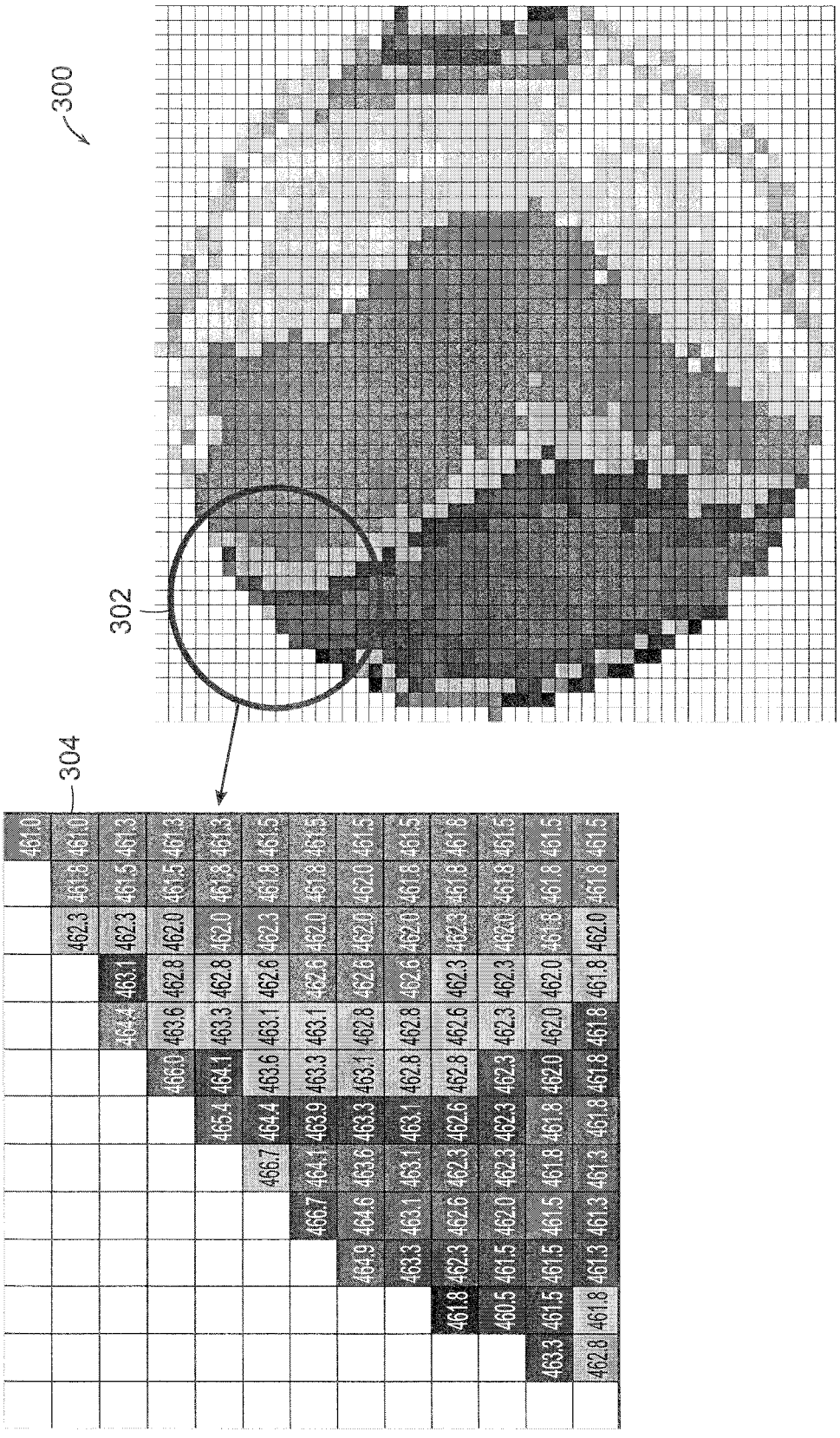


FIG. 3

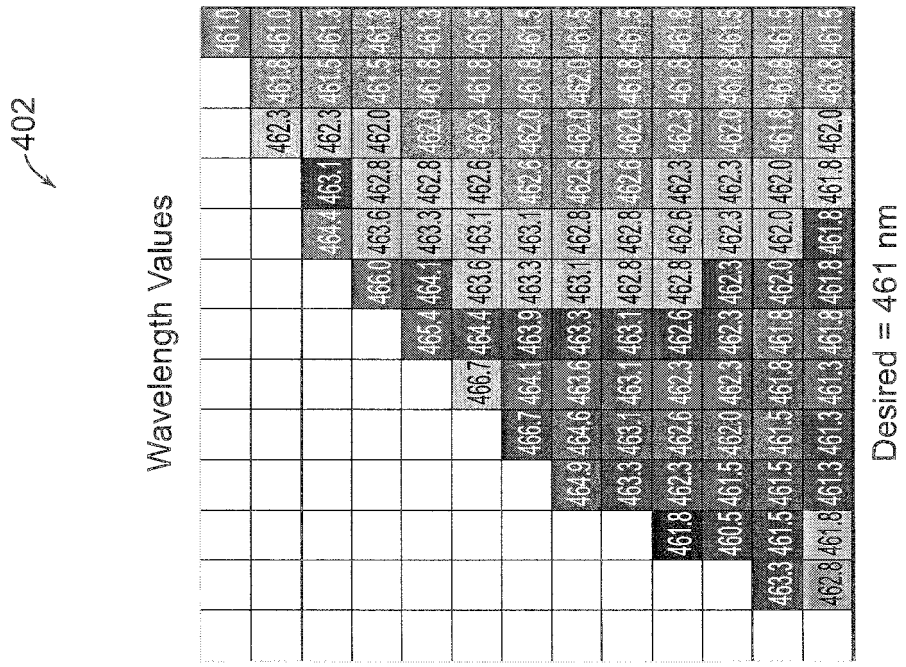


FIG. 4A

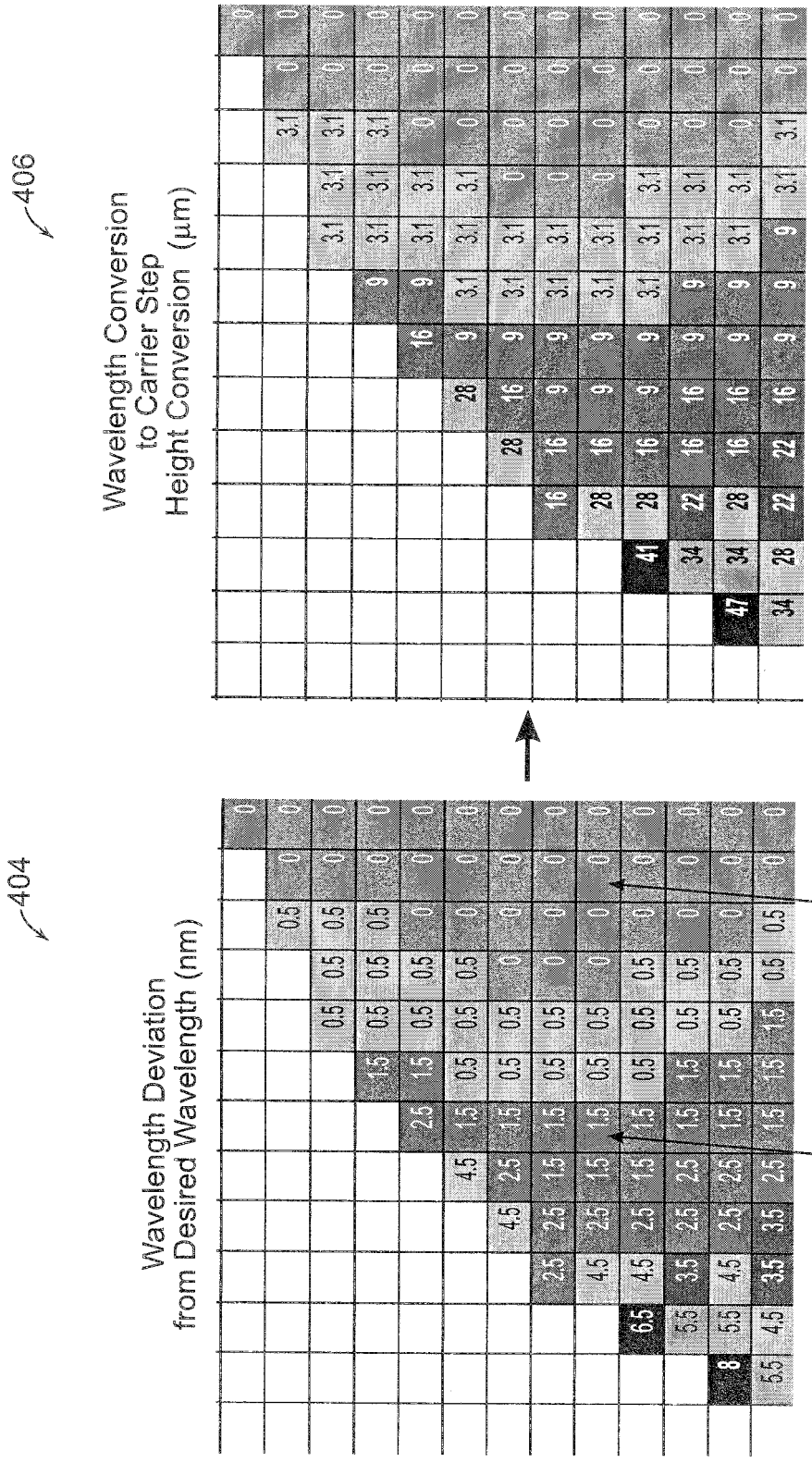

404
406
Wavelength Deviation
from Desired Wavelength (nm)
Wavelength Conversion
to Carrier Step
Height Conversion (μm)
Δλ> 0
Δλ= 0

FIG. 4B

FIG. 4C

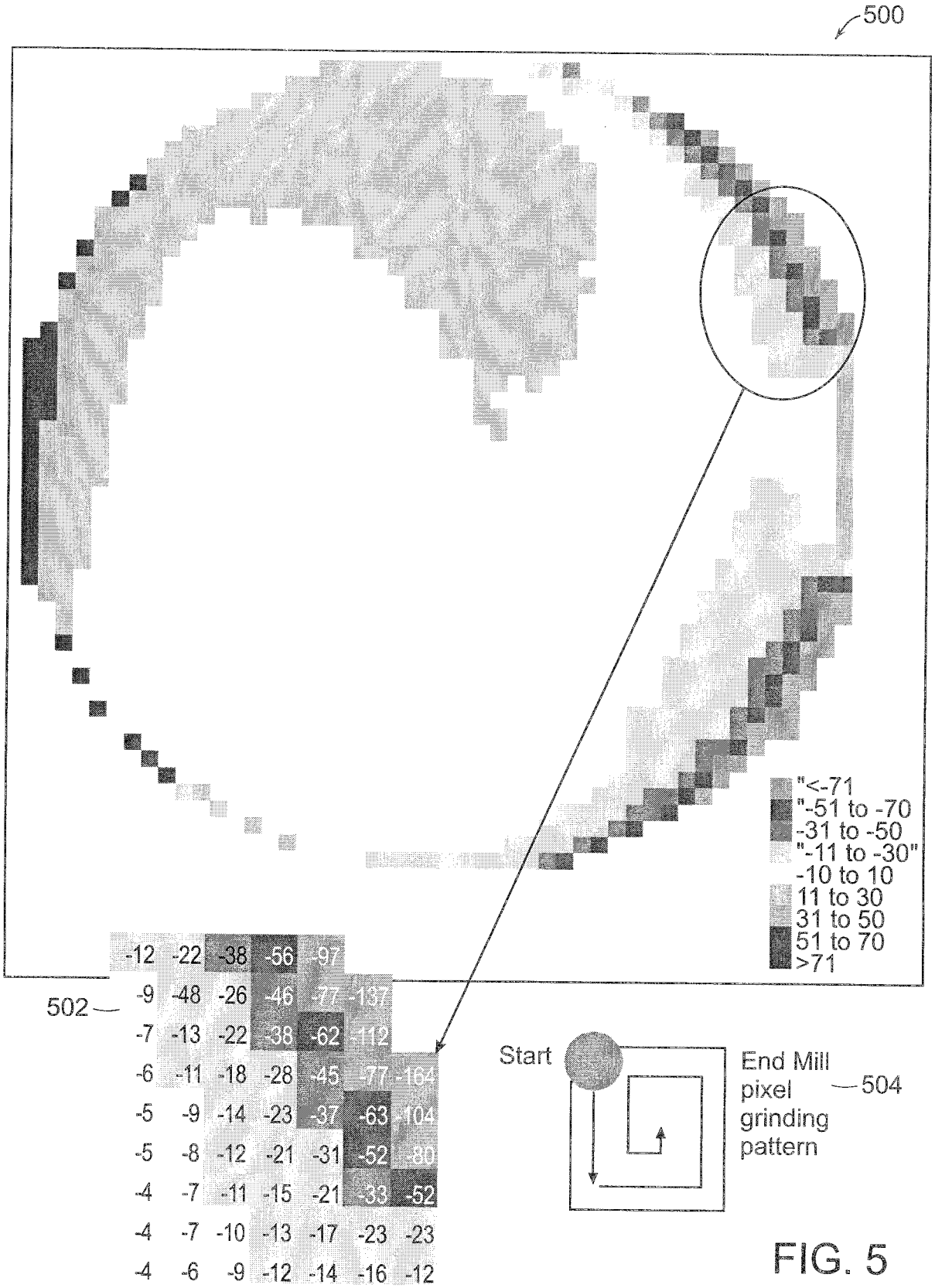

500
"<-71
"-51 to -70
-31 to -50
"-11 to -30"
-10 to 10
11 to 30
31 to 50
51 to 70
>71
502
-12 -22 -38 -56 -97
-9 -48 -26 -46 -77 -137
-7 -13 -22 -38 -62 -112
-6 -11 -18 -28 -45 -77 -164
-5 -9 -14 -23 -37 -63 -104
-5 -8 -12 -21 -31 -52 -80
-4 -7 -11 -15 -21 -33 -52
-4 -7 -10 -13 -17 -23 -23
-4 -6 -9 -12 -14 -16 -12
Start
End Mill
pixel
grinding
pattern
504

FIG. 5